

Docket No.

0160-0193-0 PCT

APR 19 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: HIRONAKA, ET AL.

SERIAL NO: 09/463,961

GAU: 1754

FILED: MAY 25, 2000

EXAMINER: VANOY, T.

FOR: METHOD AND APPARATUS FOR PROCESSING EXHAUST GAS OF SEMICONDUCTOR FABRICATION

INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 CFR 1.97

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Applicant(s) wish to disclose the following information.

(considered)

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

The references in this Information Disclosure Statement (IDS) are cited in a passage of JP 5-80243 ("JP-243"). JP-243 is related to JP 62-125,827 ("JP-827"), which is cited in the Final Rejection dated November 21, 2001. JP-827 is a publication of a patent application before examination. After examination JP-827 was published for opposition as JP-243. JP-827 was amended during examination by adding a passage disclosing the references cited in this IDS. Although Applicants have been aware of JP-827 for more than three months before the filing date of this IDS, Applicants became aware of the references added to the JP-827 disclosure in the JP-243 publication less than three months before the filing date of this IDS. Thus, the certification under 37 C.F.R. 1.97 (e)(2) is believed to be appropriate.

DEPOSIT ACCOUNT

- Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.



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